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SERIAL NUMBER 10/665,122	FILING DATE 09/22/2003 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 2557-000163/JS
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*  
*None WLL*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 REPUBLIC OF KOREA 2002-57456 09/19/2002 *WLL*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 12/11/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Metaphor <i>All waived</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 25	INDEPENDENT CLAIMS 2
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TITLE  
 Methods of fabricating a semiconductor device having a metal gate pattern

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )